

said piezoelectric substrate is a hexahedron;

said first vibrating electrode is disposed on a first side of said piezoelectric substrate perpendicular to a thickness direction;

said second vibrating electrode is disposed on a second side of said piezoelectric substrate perpendicular to the thickness direction, and faces to said first vibrating electrode;

said first pad and said second pad are respectively disposed in predetermined area having a small vibration displacement on at least one side of said piezoelectric substrate perpendicular to the thickness direction;

said first pad is made of an electrical conductor and electrically connected to said first vibrating electrode; and

said second pad is made of an electrical conductor and electrically connected to said second vibrating electrode.

13. (Amended.) A piezoelectric resonator component comprising:

a piezoelectric resonator; and

a substrate,

wherein said piezoelectric resonator is the piezoelectric resonator including:

a piezoelectric substrate;

a first vibrating electrode;

a second vibrating electrode;

a first pad; and

a second pad,

wherein:

said piezoelectric substrate is a hexahedron;